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	APPLICANT	KOMURA et al.	
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## REFERENCE DESIGNATION

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

## FOREIGN PATENT DOCUMENTS

## TRANSLATION

		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

NOT CONSIDERED		<del>Institute of Electricity Communicational Education, "University Course of Electricity Institute", Electronic Material Engineering" Pgs. 228-231, March 5, 1982</del>
NOT CONSIDERED		<del>S. Kanbara and H. Fujiwara, "Applied Physics Selection, 3. Thin Film", Pgs. 200 - 203, June 5, 1979.</del>
		translation required
EXAMINER	Bernard S. Liu	DATE CONSIDERED 07/25/02